

..... 1 of 1

U.S. PATENT & TRADEMARK OFFICE

Date of Purchase (Cyrillic)

TSMC-01-144

Agitation Machine

10/086,258

~~2~~ ~~mean~~

Ming-Hwa Yoo et al.

Filing Date

03/04/02

Group 1st Unit

~~1763~~ 1762

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

[illegible]

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

FORM PTQ-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMEX.291A	APPLICATION NO. 10/074,583
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)		APPLICANT Todd et al.	RECEIVED MAY 20 2002 TC 1700
		FILING DATE February 11, 2002	

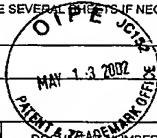
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
		60043485 A	3/8/85	Japan			Abstract	
		61153277 A	7/11/86	Japan			Abstract	
		62076612 A	4/8/87	Japan			Abstract	
		63003414 A	1/8/88	Japan			Abstract	
		63003463 A	1/8/88	Japan			Abstract	
		01217956 A	8/31/89	Japan			Abstract	
		01268064 A	10/25/89	Japan			Abstract	
		02155226 A	8/14/90	Japan			Abstract	
		03091238 A	4/18/91	Japan			Abstract	
		03185817 A	8/13/91	Japan			Abstract	
		03187215 A	8/15/91	Japan			Abstract	
		03292741 A	12/24/91	Japan			Abstract	
		04323834 A	11/13/92	Japan			Abstract	
		05021378 A	1/29/93	Japan			Abstract	
		05062011 A	3/12/93	Japan			Abstract	
		07249618 A	9/26/95	Japan			Abstract	
		08242008 A	9/17/96	Japan			Abstract	
		S60-43485	3/8/85	Japan (Patent Disclosure)			X	
		H 02-155225	6/14/90	Japan (Patent Disclosure)			X	
		H3-185817	8/13/91	Japan (Patent Disclosure)			X	
		H3-187215	8/15/91	Japan (Patent Disclosure)			X	
		H3-91239	4/16/91	Japan (Patent Disclosure)			X	
		H5-62811	3/12/93	Japan (Patent Disclosure)			X	

S:\DOCS\JOM\JOM-3155.DOC:ats
050702



EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMEX.291A	APPLICATION NO. 10/074,563
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		APPLICANT Todd et al.	
(USE SEVERAL SHEETS IF NECESSARY)		FILING DATE February 11, 2002	GROUP 1762

RECEIVED
MAY 20 2002
TC 1700



U.S. PATENT DOCUMENTS

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	4,363,828	12/14/82	Brodeky et al.			
	4,495,218	1/22/85	Azuma et al.			
	4,585,871	4/29/86	Kitagawa et al.			
	4,684,542	8/4/87	Jasinski et al.			
	5,227,329	7/13/93	Kobayashi et al.			
	5,607,724	3/4/97	Beinglass et al.			
	5,614,257	3/25/97	Beinglass et al.			
	5,648,293	7/15/97	Hayama et al.			
	5,656,531	8/12/97	Thakur et al.			
	5,695,819	12/9/97	Beinglass et al.			
	5,700,520	12/23/97	Beinglass et al.			
	5,786,027	7/28/98	Rolfson			
	5,789,030	8/4/98	Rolfson			
	5,837,580	11/17/98	Thakur et al.			
	5,874,129	2/23/99	Beinglass et al.			
5,876,797	3/2/99	Beinglass et al.				
5,885,869	3/23/99	Turner et al.				
	6,027,705	2/22/00	Kitano et al.			11/30/98
	6,083,810	7/4/00	Obeng et al.			12/5/98
	6,197,694 B1	3/6/01	Beinglass			7/31/98

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
[Signature]	57209810 A	12/23/82	Japan			Abstract	
	59078918 A	5/8/84	Japan			Abstract	
	59078919 A	5/8/84	Japan			Abstract	

EXAMINER

DATE CONSIDERED

*EXAMINER: INITIAL & CITATION CONSIDERED. WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.